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	Application No.	Applicant(s)
AL 45	10/718,207	WANG ET AL.
Notice of Allowability	Examiner	Art Unit
	Sung H. Pak	2874
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in the solution of the community or other appropriate community of the subjection is subjection in the subjection in the subjection is subjection in the	nis application. If not included cation will be mailed in due course. THIS
1. This communication is responsive to 6/13/05.		
2. X The allowed claim(s) is/are 1-10,12-17,19,20,22 and 23.		
3. $igotimes$ The drawings filed on <u>20 November 2003</u> are accepted by	y the Examiner.	
4. Acknowledgment is made of a claim for foreign priority to a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submin INFORMAL PATENT APPLICATION (PTO-152) which give (a) including changes required by the Notice of Draftspering including changes required by the attached Examined Paper No./Mail Date Identifying Indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in 7. DEPOSIT OF and/or INFORMATION about the depart attached Examiner's comment regarding REQUIREMENT	re been received. re been received in Application ocuments have been received in a memory of this communication to file a ment of this application. mitted. Note the attached EXAM res reason(s) why the oath or dust be submitted. rson's Patent Drawing Review (r's Amendment / Comment or in 1.84(c)) should be written on the the header according to 37 CFR osit of BIOLOGICAL MATER	No In this national stage application from the reply complying with the requirements IINER'S AMENDMENT or NOTICE OF eclaration is deficient. PTO-948) attached If the Office action of drawings in the front (not the back) of 1.121(d). RIAL must be submitted. Note the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. Interview Sum Paper No./Mi /08), 7. Examiner's Ar	ail Date mendment/Comment atement of Reasons for Allowance
		Sung Pak Patent Examiner AU 2874

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DETAILED ACTION

Applicants' amendment filed 6/13/2005 has been entered. Claims 1-10, 12-17, 19-20, 22-23 are now pending.

Allowable Subject Matter

Claims 1-10, 12-17, 19-20, 22-23 are allowed.

The following is an examiner's statement of reasons for allowance: Applicants' arguments regarding the patentability of pending claims are convincing. In addition, the pending claims are allowed for the following reasons.

As discussed in the previous office action, optical assemblies for aligning various optical components are well known in the art. Takada (US 6,863,452 B2) and Pham et al (US 2004/0052468 A1), cited in the previous office action, disclose such optical assemblies having meltable materials for permanently retaining alignment positions of optical components. In addition, Nakata (US 6,667,550 B2) also teaches the use of a meltable material (i.e. solder) that permanently fixes optical components in an aligned position. Meltable materials in both Pham and Nakata allow relative movements of optical components when the meltable material is in a melted-state.

However, none of the prior art fairly teaches or suggests such optical assembly comprising an alignment stage that enable relative positioning of a light source and a lens, wherein the alignment stage is supported by a thermal actuator that allows thermal actuation. Meltable materials in Nakata and Pham references may possibly be construed as a "thermal actuator" since relative positions of various optical elements are adjustable while meltable

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and meltable material both present (as separate elements) in a device as claimed in the instant application. Further more, there is no advantages or teachings in the prior art that would suggests one of ordinary skill in the art to modify the device of Nakata or Pham to have both thermal actuator and meltable material as claimed in the instant application. For these reasons, as well as the applicants' argument for patentability of pending claims discussed on pages 8-15 of the applicants' response, the application is in condition for allowance.

It is noted that Matta et al (Patent application publication US 2005/0175298A1), assigned to the same assignee and sharing some of the same inventors as the present application, discloses a device similar to that disclosed in the present application. However, the effective filing date of Matta et al. is after the effective filing date of the present application, and it claims an invention having different patentable scope than the present application.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Sung H. Pak whose telephone number is (571) 272-2353. The examiner can normally be reached on Monday- Friday, 9AM-5PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Rodney Bovernick can be reached on (571)272-2344. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Sung H. Pak
Patent Examiner

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